

PATENT

Attorney Docket No.: TI-29012 Application No.: 09/574,653

Customer No.: 23494

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
KIM et al.) Group Art Unit: 2823
Application No.: 09/574,653) Examiner: Hsien Ming LEE
Filed: May 18, 2000)
For: A TUNABLE SIDEWALL SPACER PROCESS FOR CMOS INTEGRATED CIRCUITS)))
Assistant Commissioner for Patents	

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated August 23, 2004, the period for reply having been extended for one month by a request for extension of time filed concurrently herewith, please amend the application as follows:

Amendments to the claims begin on page 2 of this paper. **Remarks** begin on page 6 of this paper.